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			Complete if Known		
INFORMATI	ON DIGG! COURS	Application Number	10/000,004 10 811,581		
	ON DISCLOSURE	Filing Date	March 4, 2002		
STATEMENT BY APPLICANT (use as many sheets as necessary)		First Named Inventor	Man Hon Cheng		
		Group Art Unit	2827		
		Examiner Name	have O To 11 and		
Sheet	of	Attorney Docket Number	SC11852HP Jasmine Clark		
Sheet	of	Attorney Docket Number	SC11852HP		

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Examiner Initials*	Cite No. 1	Document Number Number -Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevan Passages or Relevant Figures Appear
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For San	T 40	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T
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